NCN@Purdue-Intel Summer School: July 14-25, 2008

Physics of Nanoscale Transistors: Lecture 4:

Carrier Scattering in Nanoscale MOSFETs

Mark Lundstrom

Network for Computational Nanotechnology Purdue University West Lafayette, Indiana USA





outline

1) Review and introduction

- 2) Scattering theory of the MOSFET
- 3) Transmission under low V_{DS}
- 4) Transmission under high V_{DS}
- 5) Discussion
- 6) Summary



review: ballistic I-V

$$I_D = \frac{2q}{h} \int_{-\infty}^{\infty} T(E)M(E) (f_1 - f_2) dE$$
$$N = \int_{-\infty}^{\infty} [f_1(E)D_1(E) + f_2(E)D_2(E)] dE$$

$$I_{D} = WC_{ox} \left(V_{GS} - V_{T} \right) \partial p \left[\frac{1 - \mathcal{F}_{1/2} (\eta_{F2}) / \mathcal{F}_{1/2} (\eta_{F1})}{1 + \mathcal{F}_{0} (\eta_{F2}) / \mathcal{F}_{0} (\eta_{F1})} \right]$$
$$\partial p = \sqrt{\frac{2k_{B}T}{\pi m^{*}}} \frac{\mathcal{F}_{1/2} (\eta_{F1})}{\mathcal{F}_{0} (\eta_{F1})} = \upsilon_{T} \frac{\mathcal{F}_{1/2} (\eta_{F1})}{\mathcal{F}_{0} (\eta_{F1})}$$



review: ballistic transport in a MOSFET





review: filling states in a ballistic MOSFET



review: diffusive transport in a MOSFET





Nanoscale MOSFETs are neither fully ballistic nor fully diffusive; they operate in a 'quasi-ballistic' regime.

How do we *understand* how carrier scattering affects the performance of a nanoscale MOSFET?



current transmission in a MOSFET





current transmission in a MOSFET





transmisson in the presence of elastic scattering





inelastic scattering



S. Datta, *Electronic Transport in Mesoscopic Systems*, Cambridge, 1995. 11



transmision and the IV characteristic





filling states in a quasi-ballistic MOSFET





outline

- 1) Review and introduction
- 2) Scattering theory of the MOSFET
- 3) Transmission under low V_{DS}
- 4) Transmission under high V_{DS}
- 5) Discussion
- 6) Summary



scattering theory of the MOSFET

Goal:

To illustrate the influence on scattering on the I-V characteristic of a MOSFET by developing a very simple theory.

Assumptions:

- 1) Average quantities, not energy-resolved.
- 2) Boltzmann statistics for carriers

3)
$$T_{12} = T_{21} = T$$

4) Average velocity of backscattered carriers equals that of the injected carriers. ¹⁵

scattering in a nano-MOSFET



current

$$I_{D} = W\left(qn_{S}^{+}(0)\upsilon_{T} - qn_{S}^{-}(0)\upsilon_{T}\right) = Wqn_{S}^{+}\left(0\right)\upsilon_{T}\left[1 - n_{S}^{-}(0)/n_{S}^{+}(0)\right] \quad (1)$$

$$n_{s}(0) = n_{s}^{+}(0) + n_{s}^{-}(0) = n_{s}^{+}(0) \left[1 + n_{s}^{-}(0) / n_{s}^{+}(0) \right]$$
(2)





current

$$I_{D} = Wqn_{S}(0)\upsilon_{T}\left(\frac{1-n_{S}^{-}(0)/n_{S}^{+}(0)}{1+n_{S}^{-}(0)/n_{S}^{+}(0)}\right)$$

$$I_{D} = WQ_{I}(0)\upsilon_{T}\left(\frac{1 - n_{S}^{-}(0)/n_{S}^{+}(0)}{1 + n_{S}^{-}(0)/n_{S}^{+}(0)}\right)$$

Exactly the same result we had for the ballistic case, but the (- velocity) carrier density at the top of the barrier is altered by scattering.

carrier densities at the top of the barrier



from carrier densities to drain current

$$n_{S}^{-}(0) = Rn_{S}^{+}(0) + Tn_{S}^{+}(0)e^{-qV_{DS}/k_{B}T} = n_{S}^{+}(0)\left[R + (1-R)e^{-qV_{DS}/k_{B}T}\right]$$

$$\frac{n_{S}^{-}(0)}{n_{S}^{+}(0)} = R + (1 - R)e^{-qV_{DS}/k_{B}T}$$

$$I_{D} = WQ_{I}(0)\upsilon_{T}\left(\frac{1 - n_{S}^{-}(0)/n_{S}^{+}(0)}{1 + n_{S}^{-}(0)/n_{S}^{+}(0)}\right)$$

$$I_{D} = WQ_{I}(0)\upsilon_{T}\left(\frac{(1-R)-(1-R)e^{-qV_{DS}/k_{B}T}}{(1+R)+(1-R)e^{-qV_{DS}/k_{B}T}}\right)$$



the MOSFET I-V with scattering

$$I_{DS} = WC_{ox} \left(V_{GS} - V_T \right) \upsilon_T \left(\frac{1 - e^{q V_{DS} / k_B T}}{1 + e^{q V_{DS} / k_B T}} \right)$$

(ballistic, Boltzmann statistics)

$$I_{D} = WC_{ox} \left(V_{GS} - V_{T} \right) \nu_{T} \left(\frac{(1-R) - (1-R)e^{-qV_{DS}/k_{B}T}}{(1+R) + (1-R)e^{-qV_{DS}/k_{B}T}} \right)$$

$$T = (1 - R)$$

$$I_{D} = WC_{ox} \left(V_{GS} - V_{T} \right) \upsilon_{T} T \left(\frac{1 - e^{-qV_{DS}/k_{B}T}}{(2 - T) + Te^{-qV_{DS}/k_{B}T}} \right)$$

 I_D (scattering) $\neq TI_D$ (ballistic)



high drain bias

$$I_{D} = WC_{ox} \left(V_{GS} - V_{T} \right) \nu_{T} \left(\frac{(1-R) - (1-R)e^{-qV_{DS}/k_{B}T}}{(1+R) + (1-R)e^{-qV_{DS}/k_{B}T}} \right)$$



questions

- 1) We expected current to be proportional to transmission (T = 1 R), but where does the (1 + R) in the denominator come from?
- 2) How do we generalize the result for Fermi-Dirac statistics?

approximate answer:

$$I_D = WC_{ox} \left(V_{GS} - V_T \right) \partial_T \frac{\left(1 - R\right)}{\left(1 + R\right)}$$



low drain bias

$$I_{D} = WC_{ox} \left(V_{GS} - V_{T} \right) \upsilon_{T} \left(\frac{(1-R) - (1-R)e^{-qV_{DS}/k_{B}T}}{(1+R) + (1-R)e^{-qV_{DS}/k_{B}T}} \right)$$



- 1) For low V_{DS} , the drain current is proportional to transmission (T = 1 R). Why in this case but not for high V_{DS} ?
- 2) How do we generalize the result for Fermi-Dirac statistics?

approximate answer:

$$G_{CH} = \left(WC_{ox}\left(V_{GS} - V_{T}\right)\frac{\upsilon_{T}}{\left(2k_{B}T/q\right)}\right)\left[\frac{\mathcal{F}_{-1/2}\left(\eta_{F1}\right)}{\mathcal{F}_{0}\left(\eta_{F1}\right)}\right]\left(1 - R\right)$$



summary of the scattering model

$$\begin{cases} I_{D} \approx WC_{ox} (V_{GS} - V_{T}) \partial \not P \left(\frac{(1-R) - (1-R) \mathcal{F}_{1/2} (\eta_{F2}) / \mathcal{F}_{1/2} (\eta_{F1})}{(1+R) + (1-R) \mathcal{F}_{0} (\eta_{F2}) / \mathcal{F}_{0} (\eta_{F1})} \right) \\ G_{CH} \approx \left(WC_{ox} (V_{GS} - V_{T}) \frac{\upsilon_{T}}{(2k_{B}T/q)} \right) \left[\frac{\mathcal{F}_{-1/2} (\eta_{F1})}{\mathcal{F}_{0} (\eta_{F1})} \right] (1-R) \\ I_{ON} \approx WC_{ox} (V_{GS} - V_{T}) \partial \not P \frac{(1-R)}{(1+R)} \qquad I_{D} \end{cases}$$

To proceed, we need to understand $R(V_{GS}, V_{DS})$

26

 V_{DSAT}

 V_{GS}

 V_{DS}



outline

- 1) Review and introduction
- 2) Scattering theory of the MOSFET

3) Transmission under low V_{DS}

- 4) Transmission under high V_{DS}
- 5) Discussion
- 6) Summary





Consider a flux of carriers injected into a field-free slab of length, *L*. The flux that emerges at x = L is *T* times the incident flux, where 0 < T < 1. The flux that emerges from x = 0 is *R* times the incident flux, where T + R = 1, assuming no carrier recombination-generation.

How is *T* related to the mean-free-path for backscattering within the slab?



transmission

transmission (ii)



transmission (iii)

mean-free-path



How do we relate λ_0 to known parameters?

If I_1 is a thermal equilibrium injected flux, $I_1 = n^+(0)\upsilon_T$ then, it can be shown that:

$$D_n = \frac{k_B T}{q} \mu_n = \frac{\nu_T}{2} \lambda_0$$

(non-degenerate carrier statistics)



example



$$\mu_n \approx 200 \text{ cm}^2/\text{V-s}$$

$$\mu_n = \frac{\upsilon_T}{2(k_B T/q)} \lambda_0$$

 $\lambda_0 \approx 9 \text{ nm}$

 $L \approx 50 \text{ nm}$

$$T \approx \frac{\lambda_o}{L + \lambda_o} \approx 0.15$$



relation to conventional theory

$$G_{CH} = \left(WC_{ox}\left(V_{GS} - V_T\right)\frac{\upsilon_T}{\left(2k_BT/q\right)}\right)\left(1 - R\right)$$

$$1-R=T=rac{\lambda_0}{\lambda_0+L}pproxrac{\lambda_0}{L}$$
 (diffusive limit)

$$\lambda_0 = rac{2 \, k_{\scriptscriptstyle B} T / q}{
u_{\scriptscriptstyle T}} \, \mu_n$$

$$G_{CH} = \frac{W}{L} \mu_n C_{ox} \left(V_{GS} - V_T \right)$$

(non-degenerate carrier statistics)

The scattering model works in the diffusive limit, as well as the ballistic limit, and in the quasi-ballistic regime in between.

34

channel conductance

$$G_{CH} = \left(WC_{ox} \left(V_{GS} - V_T \right) \frac{\upsilon_T}{\left(2k_B T/q \right)} \right) \left[\frac{\mathcal{F}_{-1/2} \left(\eta_{F1} \right)}{\mathcal{F}_0 \left(\eta_{F1} \right)} \right] T$$

$$T_{on} = \lambda_0$$

$$I = \frac{1}{\lambda_0 + L}$$

one can show that:

$$G_{CH} = \frac{W}{L} \left(\frac{1}{\mu_n} + \frac{1}{\mu_B} \right)^{-1} C_{ox} \left(V_{GS} - V_T \right)$$

$$\mu_n = \frac{\upsilon_T \lambda_0}{2 k_B T / q} \left[\frac{\mathcal{F}_{-1/2}(\eta_{F1})}{\mathcal{F}_0(\eta_{F1})} \right]$$
$$\mu_B = \frac{\upsilon_T L}{2 k_B T / q} \left[\frac{\mathcal{F}_{-1/2}(\eta_{F1})}{\mathcal{F}_0(\eta_{F1})} \right]$$



outline

- 1) Review and introduction
- 2) Scattering theory of the MOSFET
- 3) Transmission under low V_{DS}
- 4) Transmission under high V_{DS}
- 5) Discussion
- 6) Summary



scattering model:

$$I_{ON} = WC_{ox} \left(V_{GS} - V_T \right) \partial_T \frac{\left(1 - R \right)}{\left(1 + R \right)} = WC_{ox} \left(V_{GS} - V_T \right) \partial_T \frac{T}{\left(2 - T \right)}$$

in practice:

$$B = \frac{I_{ON} \text{(measured)}}{I_{ON} \text{(ballistic)}} \approx 0.50$$

$$B = \frac{T}{(2-T)} \rightarrow T \approx 0.67 >> 0.15 \quad Why?$$



transmission across a slab with an electric field



When the electric field is strong and position-dependent and several scattering mechanisms operate, this turns out to be a <u>difficult</u> problem.

How can we understand the essential physics?



transport "downhill"



Peter J, Price, "Monte Carlo calculation of electron transport in solids," *Semiconductors and Semimetals*, **14**, pp. 249-334, 1979

$$T = \frac{\lambda_o}{\mathbf{I} + \lambda_o} \quad \ell << L$$

 $T \approx 1$: High field regions are good carrier collectors.

field-free region followed by high-field region



The base-collector of a bipolar transistor is a low-field region followed by a high-field region. **Transmission is controlled by the low-field region.**

transport in a MOS transistor



$$T \approx \frac{\lambda_o}{\mathbf{I} + \lambda_o}$$

1) A MOSFET consists of a low-field region near the source that is strongly controlled by the gate voltage, and a high-field region near the drain that is strongly controlled by the drain voltage.

- 2) Transmission is controlled by the low-field region near the source.
- Scattering near the drain has a smaller effect on backscattering to the source.
- 4) In contrast to a bipolar transistor, the division between the low and ₄₁high field regions is not sharp.

bias-dependent transmission





outline

- 1) Review and introduction
- 2) Scattering theory of the MOSFET
- 3) Transmission under low V_{DS}
- 4) Transmission under high V_{DS}
- 5) Discussion
- 6) Summary



computing the critical length



$$T \approx \frac{\lambda_o}{\mathbf{I} + \lambda_o}$$

Assuming near-equilibrium transport in the low-field region (i.e. DD), one can show that the critical length is the distance over which the channel potential drops by k_BT/q

'*kT* layer"
$$\ell pprox L_{k_bT}$$

Two key assumptions:

- 1) near-equilibrium
- 2) Boltzmann statistics



physics of elastic back-scattering



physics of elastic back-scattering

46



*x*₁ < 1

probability of returning to the source is high

$x_1 > \mathbf{I}$ probability of returning to the source is low

$$q\Delta V(|) \approx E_i - \varepsilon_1(0)$$

See: Lundstrom and Ren, *IEEE Trans. Electron Dev*, **49**, pp. 133-141, 2002.



physics of elastic back-scattering

47



For non-degenerate carriers,

$$\left\langle E_i - \varepsilon_1(0) \right\rangle = k_B T$$

 $q\Delta V(\mathsf{I}) \approx k_{\scriptscriptstyle B} T$

Above threshold, however,

$$\langle E_i - \varepsilon_1(0) \rangle > k_B T$$

See: Lundstrom and Ren, *IEEE Trans. Electron Dev*, **49**, pp. 133-141, 2002.

role of inelastic scattering

If an electron backscatters by emitting a phonon, it is less likely to return to the source even if it is pointed in the right direction.

$$L_{k_BT} \rightarrow$$
 "h ω length"

K. Natori, *IEEE Electron Dev. Lett.*, **23**, pp. 655-657, 2002.

drift-diffusion picture

$$I_D = WC_{ox} \langle \upsilon(0) \rangle (V_{GS} - V_T)$$
$$\frac{1}{\langle \upsilon(0) \rangle} = \frac{1}{\upsilon_T} + \frac{1}{D_n/\mathsf{I}} \qquad D_n = (k_B T / q) \mu_n$$

drift-diffusion vs. scattering model

$$I_{D} = WC_{ox} \left[\frac{1}{\upsilon_{T}} + \frac{1}{(D_{n}/1)} \right]^{-1} (V_{GS} - V_{T})$$
drift-diffusion
$$D_{n} = \upsilon_{T} \lambda_{0}/2 \qquad T = \frac{\lambda_{0}}{\lambda_{0} + 1}$$
$$I_{D} = WC_{ox} \frac{T}{2 - T} \upsilon_{T} (V_{GS} - V_{T})$$
scattering

Detailed, numerical simulations confirm the basic physical picture that we have presented, but they show that the critical layer is somewhat longer than L_{kT} and that it depends on the shape of the potential profile. Under some conditions, inelastic scattering can even increase the d.c. current.

See, for example:

P. Palestri, R. Clerc, D. Esseni, L. Lucci, and L. Selmi, "Multi-subband Monte Carlo investigation of the mean free path and of the kT layer in degenerated quasi-ballistic nanoMOSFETs, IEDM Tech. Dig.,pp. 945-948, Dec. 2006.

Raseong Kim and Mark Lundstrom, "Physics of carrier backscattering in one- and two-dimensional nanotransistors," submitted for publication, June, 2008.

outline

- 1) Review and introduction
- 2) Scattering theory of the MOSFET
- 3) Transmission under low V_{DS}
- 4) Transmission under high V_{DS}
- 5) Discussion
- 6) Summary

summary

- 1) Modern MOSFETs operate between the ballistic and diffusive limits, so we need to understand transport in the quasi-ballistic regime.
- 2) Transmission (or scattering) theory provides a simple, physical description of quasi-ballistic transport.
- 3) The same physics can also be understood at the drift-diffusion level.
- 4) Quantitative treatments require detailed numerical simulation.

